Abstract of the Disclosure

A cleaning apparatus comprises nozzle means having an ejection port, a cleaning liquid path communicating with the ejection port, and a compressed gas path communicating with the ejection port. The cleaning apparatus further comprises cleaning liquid feeding means for feeding a cleaning liquid to the cleaning liquid path, and compressed gas feeding means for feeding a compressed gas to the compressed gas path. The compressed gas is ejected from the ejection port through the compressed gas path, while the cleaning liquid is ejected from the ejection port through the cleaning liquid path.

This Sheet Has Been Replaced

